

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination HIRAO, SHUJI	
		10/624,564 <i>AS4100</i>	Examiner Edna Wong	Art Unit 1753

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	C	US-6,610,189	08-2003	Wang et al.	205/88
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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